PATENT

Docket No.: 29284/541

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

LICANTS:

SERIAL NO.:

FILED

FOR

ARA, Yasuhiko et al.

9/832,220

April 11, 2001

INSPECTION METHOD, APPARATUS AND SYSTEM FOR CIRCUIT PATTERN

ART UNIT

EXAMINER:

ASSISTANT COMMISSIONER FOR PATENTS

Washington, DC 20231

AMENDMENT

SIR:

In response to the Office Action of August 24, 2001, the period for response having been extended herein to February 25, 2002 (February 24th falls on a Sunday) by payment of the requisite fee of \$920.00 for a Petition for Extension of Time Under 37 C.F.R. § 1.136(a), kindly amend the aboveidentified application as follows:

IN THE CLAIMS:

Cancel claims 6-8 without prejudice. Amend the following claims:

1. (Amended) An inspection apparatus for a circuit pattern, comprising:

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